

<b>Notice of References Cited</b>	Application/Control No. 10/714,654	Applicant(s)/Patent Under Reexamination TAKEKOSHI ET AL.	
	Examiner Randolph Chu	Art Unit 2624	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,822,676	11-2004	Kurosawa et al.	348/211.3
*	B	US-2004/0062421	04-2004	Jakubowski et al.	382/115
	C	US-			
	D	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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